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26522 La Alameda Avenue, Suite 360
Mission Viejo, California 92691
tel: (949) 282-1000
fax: (949) 282-1002

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Date: September 15, 2005

To: United States Patent and Trademark Office
Examiner: Pham, Long; Art Unit: 2814

Fax: (571) 273-8300

Re: **Application Serial No.: 10/761,009**
Filing Date: 1/20/2004; First-Named Inventor: Jeon
Attorney Docket No.: 0180154

From: Farjami & Farjami LLP

Number of pages including the cover sheet: 10

Message:

Enclosed please find the Amendment and Response to Final Office Action dated July 26, 2005.

Thank you.

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Attorney Docket No.: 0180154

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re Application of: **Jeon, et al.**

Art Unit: 2814

Serial No.: 10/761,009

Examiner: Pham, Long

Filed: 01/20/2004

For: **Method for Forming a Thin, High
Quality Buffer Layer in a Field Effect
Transistor and Related Structure**

AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir/Madam:

This is in response to the Final Office Action dated July 26, 2005 in the above-referenced patent application. Please enter and consider the following amendments and remarks.